

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: DOUGLAS, Stephen B. et al. Group Art Unit: 3754

Serial No. 10/634,458

Examiner:

Filed: 08/05/2003

Dkt No: SCF02A-CIP

For: SUPERCRITICAL FLUID DELIVERY SYSTEM FOR SEMICONDUCTOR WAFER
PROCESSINGTo: Commissioner for Patents
PO Box 1450
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24222

CERTIFICATE OF FACSIMILE TRANSMISSION: I certify that this paper is being transmitted by facsimile to the
Commissioner of Patents to the attention of GAU 3754 at facsimile # 703-872-9306 on the date shown below.

Date:

10/11/04

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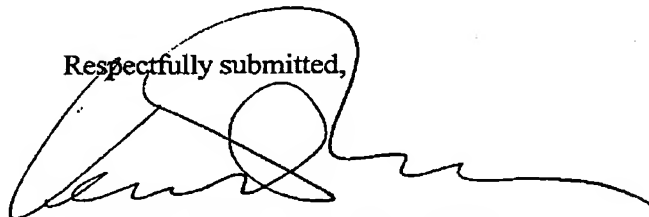
Dear Examiner:

STATUS INQUIRY

This is to inquire as to the current status of the above-referenced application.

☒ [X] The above application was filed by express mail on 08/05/2003, and a formal filing receipt:☒ [X] was mailed on 11/03/2003 and received on 11/05/2003.☐ [] has not been received.☒ [X] Notice of Publication received on 02/25/2004.☒ [X] No further response has been received from the Patent and Trademark Office. Please advise
the undersigned by phone, fax or otherwise of the status of this application and indicate when we
may expect the next official communication.

Respectfully submitted,



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